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## Emerging Applications in Silicon Photonics II

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## **Contents**

	EMERGING APPLICATIONS IN SILICON PHOTONICS I
11880 06	Camera-based metrology of subwavelength scatterers in photonic integrated circuits [11880-23]
	EMERGING APPLICATIONS IN SILICON PHOTONICS II
11880 0A	Developing optomechanical inertial sensors (Invited Paper) [11880-8]
	EMERGING APPLICATIONS IN SILICON PHOTONICS III
11880 OF	Fabrication tolerant design of silicon nitride Kerr comb generators [11880-13]
	H2020 PICTURE PROJECT
11880 01	Wide-wavelength range AlGalnAs laser array achieved by selective area growth on heterogenerous InP-on-Si wafer (Invited Paper) [11880-15]
11880 OL	Electro-optic co-design for next generation silicon optical transmitters (Invited Paper) [11880-18]
11880 OM	Novel technology of III-V die-bonded SOI photonic integrated circuits (Invited Paper) [11880-19]